	Application No.	Applicant(s)	
	09/940,544	LEE, JOUN HO	
Notice of Allowability	Examiner	Art Unit	
	Steven H. Rao	2814	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject to	plication. If not included will be mailed in due course. The	
1. This communication is responsive to <u>7/29/05</u> .		•	
2. X The allowed claim(s) is/are 1-3,6-9,11 and 20-27.			
3. X The drawings filed on 29 August 2001 are accepted by the	Examiner.		
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application No		he
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements	S .
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			=
6. CORRECTED DRAWINGS (as "replacement sheets") mus	et be submitted.		
(a) including changes required by the Notice of Draftspers	•	948) attached	
1) hereto or 2) to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	Office action of	
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the drawi he header according to 37 CFR 1.121(ngs in the front (not the back) of d).	
7. DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	<u>—</u>	Patent Application (PTO-152)	·
	6. ☐ Interview Summary Paper No./Mail Da	te	
 Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 	8), 7. ⊠ Examiner's Amendr	ment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Stateme 9. □ Other	ent of Reasons for Allowance	
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Response to Amendment

Applicants' amendment filed on June 22, 2005 was entered on June 29, 2005 and the Supplemental amendment faxed on July 29, 2005 has been entered on July 29, 2005.

Therefore claims 1 and 20 as amended by the Supplemental amendment and claims 3, 6-9, 11 and 21-22 and 24-27 as previously recited are currently pending the Application.

Claims 4,10 were previously cancelled and 12-19 drawn to nonelected invention have been cancelled by the Supplemental amendment filed on July 29, 2005.

Claims 5 and 23 have been cancelled by the examiner's amendment below as authorized by Attorney Valeri Hayes (53,005) on July 29, 2005.

EXAMINER'S AMENDMENT

The Application has been amended as follows.

In The Claims

Cancel claims 5 and 23, the subject matter of these claims have been incorporated by the Supplemental amendment in to independent claims 1 and 20 respectively.

The above examiner's amendment was authorized by Attorney Valeri P. Hayes (53,005) on July 29, 2005.

Allowable Subject Matter

Claims 1-3,6-9,11,20-22 and 24-27 are allowed.

The prior art taken either singularly or in combination fails to anticipate or fairly suggest the limitation of the dependent claims, in such manner that a rejection under 35 U.S.C. 102 or 103 would be proper. The applied prior art fails to teach a combination of all the claimed features as presented in independent claims 1 and 20 which include An inplane switching mode liquid crystal display device including first and second substrates having a liquid crystal layer there between, gate and data lines arranged to cross each other on the first substrate to define a plurality of pixel regions, a plurality of common and data electrodes on the first substrate that apply an electric field to the liquid crystal layer that is parallel to the first substrate and at least one dummy pattern overlapping at least one portion of the data lines for repairing at least an open region of the data lines wherein the portion of the data lines overlapped with the dummy pattern is electrically connected to the dummy pattern and wherein the dummy pattern is integral (as described in the Applicants' specification pages 5 lines 15-18 and page 8 lines 25-30 and figure 3 # 39; 39 a and 41, etc.) with at least one of the common electrodes and is of a same material as the common electrode.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Steven H. Rao whose telephone number is (571) 272-1718. The examiner can normally be reached on 8.00 to 5.00.

The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306 (up to 09/15/ 2005) also (571-272-3800 after 07/15/2005).

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Steven H. Rao

Patent Examiner

July, 29, 2005.

LONG PHAM
PRIMARY EXAMINER